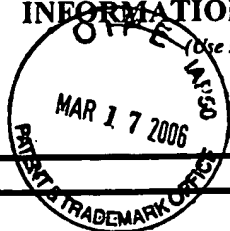


INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small>	Docket number (Optional)	Application Number
	15689.63.1	10/912,750
	Applicant(s)	
	Mikio Iwamura, et al.	
	Filing Date	Group Art Unit
	08/04/2004	2681



U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	1	5,722,043	02/24/1998	Rappaport et al.	455	33.1	07/25/1995

U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

EXAMINER	ELISEO RAMOS-FELICIANO PRIMARY EXAMINER <i>[Signature]</i>	DATE CONSIDERED	8/18/06
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.